



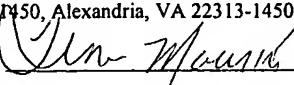
Attorney Docket No.: YOR920030174US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Applicant(s) Babich et al.  
Docket No.: YOR920030174US1  
Serial No.: 10/634,667  
Filing Date: August 5, 2003  
Group: 1752  
Examiner: Amanda C. Walke

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature: 

Date: April 18, 2006

Title: Lithographic Antireflective Hardmask Compositions and Uses Thereof

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§1.56, 1.97 and 1.98, Applicants' attorney wishes to bring to the attention of the Patent and Trademark Office the following documents listed on the accompanying PTO Form 1449. Pursuant to 37 C.F.R. §1.97(e)(1), each of the identified references were first cited in a Japanese Office Action dated February 25, 2003 (i.e., not more than three months prior to the filing of this Information Disclosure Statement). A copy of each listed document is enclosed.

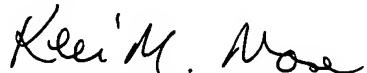
Foreign Document

1. EP 1 271 634 A2

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The filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made, or as an admission that the information cited is considered to be material to patentability or as a representation that no other material information exists.

Respectfully submitted,

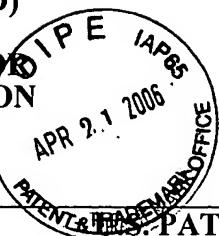


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Dated: April 18, 2006

**FORM PTO-1449 (MODIFIED)****LIST OF PUBLICATIONS FOR  
APPLICANT'S INFORMATION  
DISCLOSURE STATEMENT**

Applicant(s): Babich et al.  
 Docket No.: YOR920030174US1  
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**PATENT DOCUMENTS**

<b>EXAMINER</b>				<b>FILING DATE</b>	
<b>INITIAL</b>	<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS/SUBCLASS</b>	<b>IF APPROPRIATE</b>

**FOREIGN PATENT DOCUMENTS**

<b>EXAMINER</b>				<b>TRANSLATION</b>		
<b>INITIAL</b>	<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS/SUBCLASS</b>	<b>YES</b>	<b>NO</b>
	EP 1 271 634 A2	02/01/03	Europe			

**OTHER DOCUMENTS**

<b>EXAMINER</b>			
<b>INITIAL</b>	<b>REF NO.</b>	<b>AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.</b>	

Examiner

Date Considered

**Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.